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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): YOKOGAWA, et al

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For: PLASMA PROCESSING SYSTEM AND METHOD

Group: 1763

Examiner: L. Alejandro



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**SUBMISSION OF DOCUMENTS UNDER 37 CFR §1.56
PURSUANT TO THE DUTY OF DISCLOSURE**

Commissioner for Patents
Washington, D.C. 20231

July 1, 2002

Sir:

In order to comply with the Duty of Disclosure under 37 CFR §1.56, applicant(s) enclose herewith a copy of the document listed in the attached PTO-1449 equivalent.

Consideration of the document is respectfully requested.

Respectfully submitted,

Melvin Kraus
Registration No. 22,466
ANTONELLI, TERRY, STOUT & KRAUS, LLP

MK/cee
(703) 312-6600